

Notice of References Cited	Application/Control No. 10/692,484	Applicant(s)/Patent Under Reexamination JEONG ET AL.	
	Examiner Rip A. Lee	Art Unit 1713	Page 1 of 1

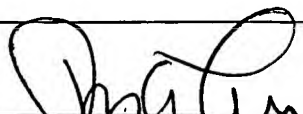
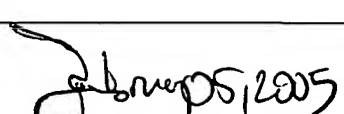
U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,506,495 B1	01-2003	Enami et al.	428/424.8
	C	US-6,218,474 B1	04-2001	Valligny et al.	525/194
	D	US-			
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	I	US-			
	J	US-			
	K	US-			
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	M	US-			

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	N	JP 2000-204207 A	07-2000	Japan	Enami et al.	C08L 23/10
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NON-PATENT DOCUMENTS

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	U	JP 2000-204207 (English translation)
	V	JP 10-287775, October 27, 1998 (abstract in English only).
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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